



Form PTO-1449 (Rev. 8-88)	Attorney Docket No. ILL02-023-DIV-US	Serial No. 10/670,585
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Applicant: Chang Liu, et al.	
	Filing Date: September 25, 2003	Group: 2881

Examiner Initials*		OTHER ITEMS - NON PATENT LITERATURE DOCUMENTS
		Include, as applicable: Author, Title, Date, Publisher, Edition or Volume, Pertinent Pages
	C1	Niklaus, F., "Void-Free Full Wafer Adhesive Bonding", presented at MEMS'00, Miyazaki, Japan, Jan. 23-27, 2000, pp. 323-328, Miyazaki, Japan.
	C2	Pierret, Robert F., Semiconductor Device Fundamentals, Table 1.1, (1995), Addison-Wesley, page 4.

Examiner 	Date Considered 7/12/2005
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.